

RECEIVED

MAY 24 2000

TC 2800 MAIL ROOM

GAU 2851  
H1618  
JL  
XA-7889A Re  
3/24/00

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kenji NISHI

Appln. No.: 08/994,758



Group Art Unit: 2851

Filed: December 19, 1997

Examiner: A. Mathews

For: PROJECTION EXPOSURE APPARATUS

\* \* \*

SUPPLEMENTAL AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Supplementing the Amendment filed May 11, 2000, please further amend the above-identified patent application as indicated below.

IN THE CLAIMS:

Please add the following claims:

1       --171. An apparatus according to Claim 143, wherein  
2       said first stage holds the original and said second stage  
3       holds the substrate, and wherein said first stage is  
4       provided above said second stage.--

1       --172. A scanning exposure method in which in  
2       synchronism with movement of a first object formed with a